


	ATTY. DOCKET NO. 2000P03099WOUS		SERIAL NO.
			
	APPLICANT Siemens Aktiengesellschaft		
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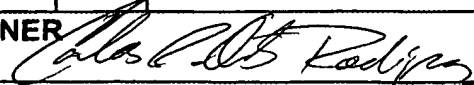
U.S. PATENT DOCUMENTS

EXAMINER INITIAL		PATENT NUMBER	ISSUE DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
OR	AA	4,595,340	17.Jun. 1986	Klassen David			
OR	AB	5,407,326	18. April 1995	Lerdellier, Alain			
OR	AC	3,695,778	03.Oct. 1972	Taylor, John			

FOREIGN PATENT OR PUBLISHED FOREIGN PATENT APPLICATION

		DOCUMENT NO.	PUBL. DATE	COUNTRY OR PATENT OFFICE	CLASS	SUB CLASS	TRANSLATION YES NO
OR	AD	EP 0,924,381	23. Jun. 1999	EPO			

OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication)

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		SEP 17 2002	
		GROUP 3600	
		EXAMINER	DATE CONSIDERED
		9/16/05	
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ATTY DOCKET NO.
32860-000280/US

APPLICATION NO.
10/084.154

APPLICANT
Christiane FOERTSCH et al.

CONF. NO.	4901
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(Use several sheets if necessary)

FILING DATE
February 28, 2002

GROUP	UNKNOWN
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[illegible]

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION	
						YES	NO
CR	DE 196 14 789 C1	9/25/97	GERMANY			PART. ABST.	
CR	DE 199 18 810 A1	11/2/00	GERMANY			PART. ABST.	
CR	DE 196 30 415 A1	1/15/98	GERMANY			PART. ABST.	
CR	DE 299 14 463 U1	11/2/2000	GERMANY				X

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OTHER DOCUMENTS (Include Name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) title page(s), volume-issue number(s), publisher, city and/or country where published.

CR	WOLFGANG KÄFER ET AL: "Konfigurierungskonzepte für DB-basierte technisch Entwurfsanwendungen", <u>Informatik Forschung und Entwicklung</u> , pp. 1-17, 1998.
CR	PETER VAN DEN HAMER ET AL.: "Managing Design Data: The Five Dimensions of CAD Frameworks, Configuration Management, and Product Data Management", <u>Proceedings of the IEEE</u> , Vol. 84, No. 1, pp. 42-56, January 1996.
CR	REINHARD SCHRIEBER: "Planungsmethoden und Planungswerkzeuge für die Prozeßleittechnik", <u>ATP</u> , pp. 41-54, June 1994.

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.